PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE: NEW ASSIGNMENT

NATURE OF CONVEYANCE: EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE

CONVEYING PARTY DATA

Name	Execution Date
Massachusetts Institute of Technology	09/21/2005

RECEIVING PARTY DATA

Name:	National Science Foundation
Street Address:	4201 Wilson Blvd
Internal Address:	Room 1265
City:	Arlington
State/Country:	VIRGINIA
Postal Code:	22230

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	11186735

CORRESPONDENCE DATA

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Total Attachments: 1 source=29#page1.tif

PATENT 501185878 REEL: 024435 FRAME: 0209

LICENSE TO THE UNITED STATES GOVERNMENT

WHEREAS, Thomas Feurer, Thomas Stephan Hornung, Keith A. Nelson and Joshua Charles Vaughan have invented, "Diffraction-Based Pulse Shaping with a 2D Spatial Light Modulator" and filed a patent application there on in the United States, entitled: "Diffraction-Based Pulse Shaping with a 2D Optical Modulator" and bearing Serial Number 11/186,735 and filing date July 21, 2005; and

WHEREAS, the invention was made in the course of research supported by the National Science Foundation under N.S.F. Grant No. CHE-0212375; and

WHEREAS, the United States Government is entitled to certain rights in and to said invention and application by reason of the terms relating to such support; and

WHEREAS, the Massachusetts Institute of Technology, hereinafter called the "Licensor" has acquired by assignment from the inventors the entire right, title and interest of the inventors to such invention;

NOW, THEREFORE:

- 1. The Licensor, in consideration of the premised and other good and valuable consideration, hereby grants and conveys to the United States Government a non-exclusive, non-transferable, paid-up license to make, use and sell the invention throughout the world by or on behalf of the Government of the United States and states and domestic municipal governments under the aforesaid patent application and any and all divisions or continuations, and in any and all patents or reissues which may be granted thereon during the full term or terms thereof.
- 2. The Licensor covenants and warrants that he has the right to grant the foregoing license, and that any assignment or license which he may make of the invention or the said patent application or patents thereon, shall expressly be make subject to this license.
- 3. The Licensor agrees that the Government shall not be estopped at any time to contest the enforceability, validity, scope of or title to any patent or patent application herein licensed.
- 4. This License shall not limit the rights reserved to the Government under the contract(s), grant(s), or other arrangement(s) under which said invention was made.

Signed this 21st day of September, 2005.

RECORDED: 05/25/2010

MASSACHUSETTS INSTITUTE OF TECHNOLOGY	
Lauren Trottier Rotent Compliance Administrator	
Patent Compliance Administrator	
Technology Licensing Office	
77 Massachusetts Avenue, Room NE25-230, Cambridge, MA 02139	
Accepted for the benefit of the Government this	
Patent Paralegal	

PATENT REEL: 024435 FRAME: 0210